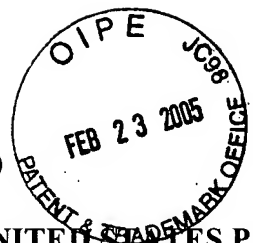


IFW



Docket No.: 60188-700

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
	:	
Toyoji ITO, et al.	:	Confirmation Number: 6781
	:	
Application No.: 10/705,984	:	Group Art Unit: 2826
	:	
Filed: November 13, 2003	:	Examiner: ERDEM, FAZLI
	:	
For: SEMICONDUCTOR DEVICE AND METHOD FOR FABRICATING THE SAME		

AMENDMENT UNDER 37 C.F.R. § 1.111

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated December 3, 2004, having a shortened statutory period for response set to expire March 3, 2005, please amend the above-identified application as follows: